

<b>Notice of References Cited</b>	Application/Control No. 10/521,025		Applicant(s)/Patent Under Reexamination LEE ET AL.	
	Examiner Monique R. Jackson		Art Unit 1794	Page 1 of 1

#### U.S. PATENT DOCUMENTS

*		Document Number Country Code-Number-Kind Code	Date MM-YYYY	Name	Classification
*	A	US-6,632,274	10-2003	Kawamoto et al.	106/286.4
*	B	US-6,992,431	01-2006	Ito et al.	313/478
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	K	US-			
	L	US-			
	M	US-			

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#### NON-PATENT DOCUMENTS

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